

# From Femtoseconds to Gigaseconds: The SolDeg Project to Analyze Si Heterojunction Cell Degradation with Machine Learning

- I. Degradation in Si-only heterojunctions
- II. Experimental degradation study
- III. Development of a Machine-Learning based Si-H interatomic potential
- IV. Degradation in c-Si/a-Si:H heterojunctions

Davis Unruh (UCD – Argonne)  
Reza Vatan (ASU)  
Zitong Zhao (UCD)  
Salman Mazoor (ASU)  
Andrew Diggs (UCD)  
Stephen Goodnick (ASU)  
Mariana Bertoni (ASU)  
**Gergely Zimanyi (UCD)**

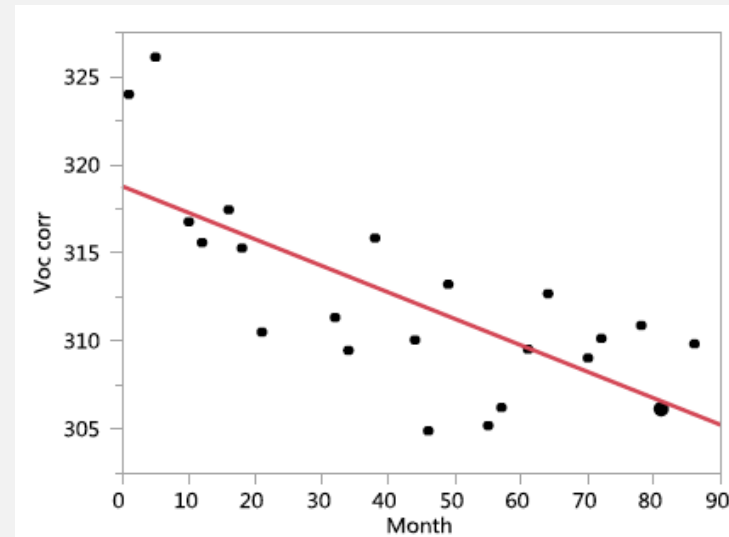


# Motivation

1. Si Heterojunction cells hold Si world record efficiency of 26.7%
2. Some groups reported efficiency degradation of 1%/yr, twice the usual. 0.5%/yr was attributed to Voc.
3. Eliminating this 0.5%/yr degradation would have the effect of increasing the efficiency by close to 2% in terms of LCOE, based on the System Advisor Model

#### 4. Bertoni: "The defects did it!"

Investigated c-Si/a-Si stacks. Reported strong increase of SRV over 28 months. Attributed it to the increase of defect density at the interface.



D. Jordan et al., IEEE J. of Photovoltaics, 8, 177 (2018)

On the other hand, the modeling reveals that during the 28-month storage period the density of defect states at the interface,  $N_S$ , has increased by an order of magnitude, that is  $(5.5 \pm 1.5) \times 10^7 \text{ cm}^{-2}$ . This  $N_S$  variation results in a strong SRV

Bernardini and Bertoni Phys. Status Solidi A 2018, 1800705

# I. The SolDeg platform

We developed the SolDeg platform to analyze the formation of defects at the c-Si/a-Si interface

This requires

- connecting extreme time scales from femtoseconds to gigaseconds (20 years)
- simulation of large number of large samples with extreme precision

**1.** Create c-Si/a-Si stacks

**2.** Generate shocked clusters at the c-Si/a-Si interface as likely hosts of electronic defects

**3.** Identify shocked clusters that actually host electronic defects

**4.** Determine the energy barriers that control the generation of these electronic defects

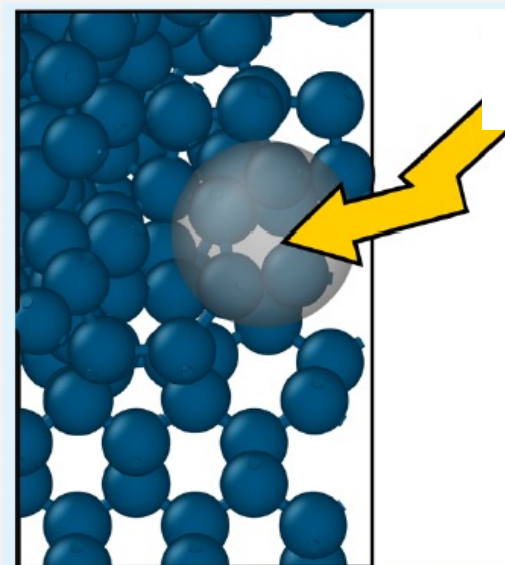
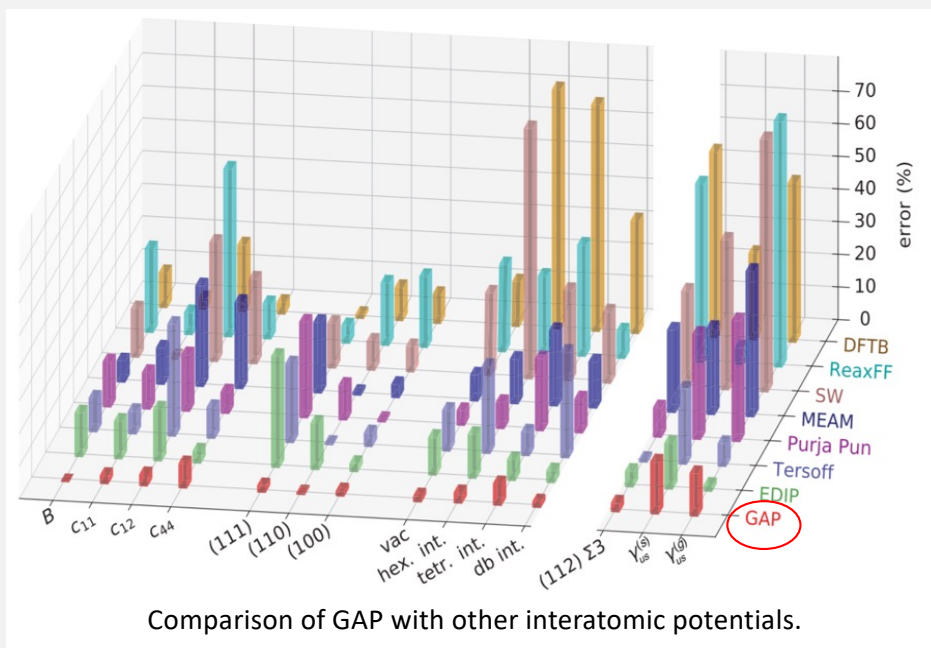
**5.** Determine the distribution of these barriers

**6.** Determine the defect generation from the energy barrier distribution

# Extreme Precision by Machine Learning-developed Potentials

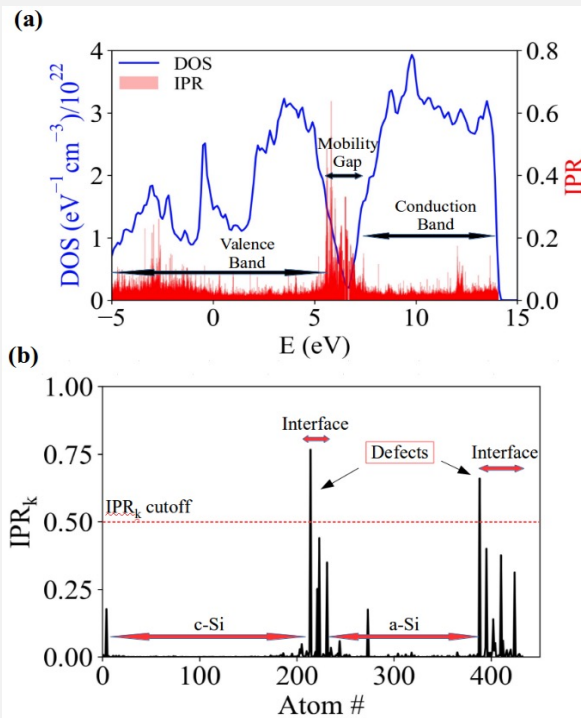
1. Create c-Si/a-Si stacks using Molecular Dynamics with **Machine-Learning** (ML)-developed Si-Si potential: Gaussian Approximation Potential Si GAP.

2. Generate shocked clusters at the c-Si/a-Si interface with “**cluster-blast**” as likely hosts of electronic defects



# Connect decades of time scales: Nudged Elastic Band method

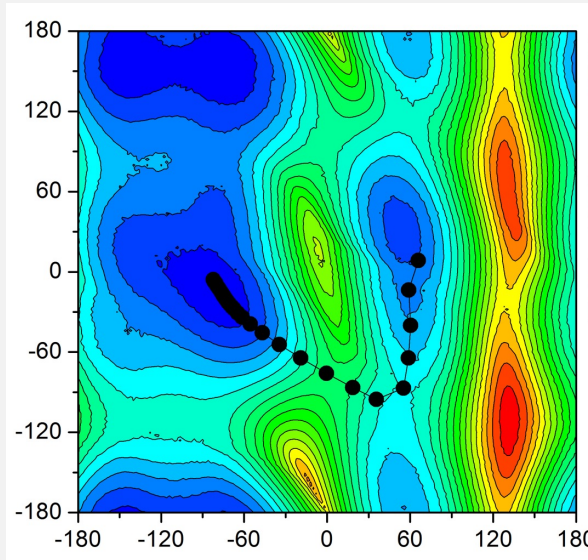
3. Identify shocked clusters that actually host electronic defects: IPR



(a) IPR as a function of energy, (b) IPR as a function of z-depth

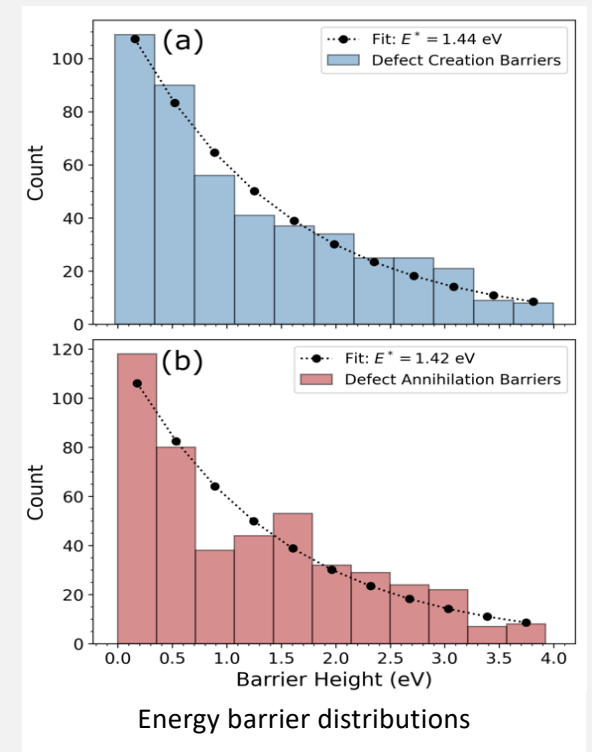
4. Determine energy barriers that control the generation of the electronic defects

**Nudged Elastic Band method** to determine energy barriers



$$\exp(1\text{eV}/300\text{K}) \sim 10^{13}$$

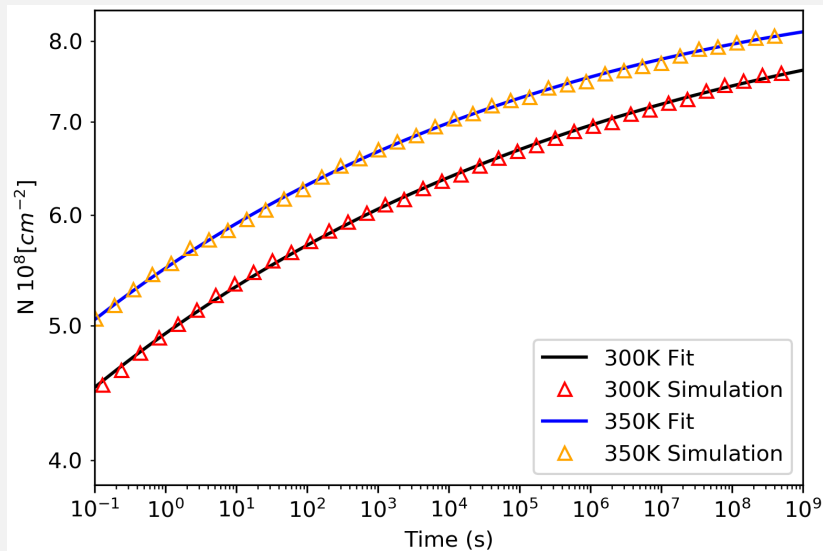
5. Determine the barrier distribution



# Determine and Analyze Dynamics of Defect Generation

6. Determine the defect generation from the energy barrier distribution

Accelerated Superbasin Kinetic Monte Carlo



$$N(t) = N_{\text{sat}}(1 - \exp[-(t/\tau_0)^\beta])$$

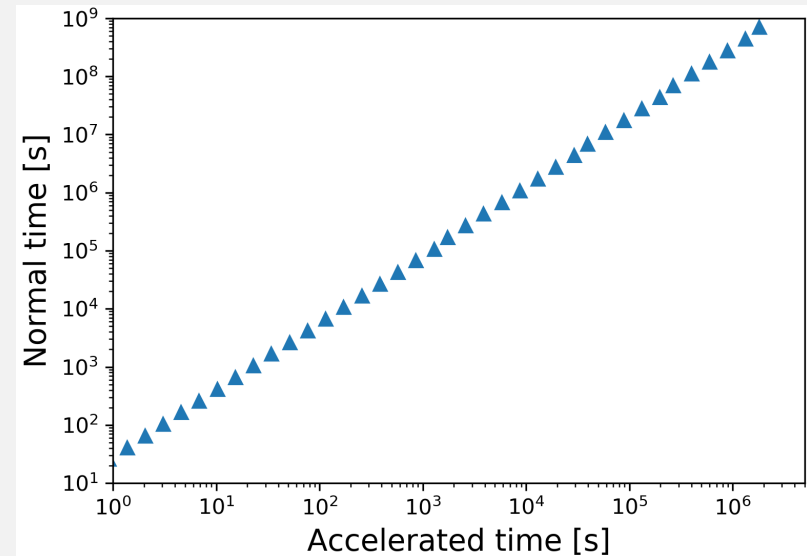
Stretched exponential fits very well

Accelerated testing by elevated temperature:

Quantitative correspondence?

Stretched exponential predicts:

$$t(\text{norm}) \sim t(\text{acc})^{T(\text{acc})/T(\text{norm})}$$



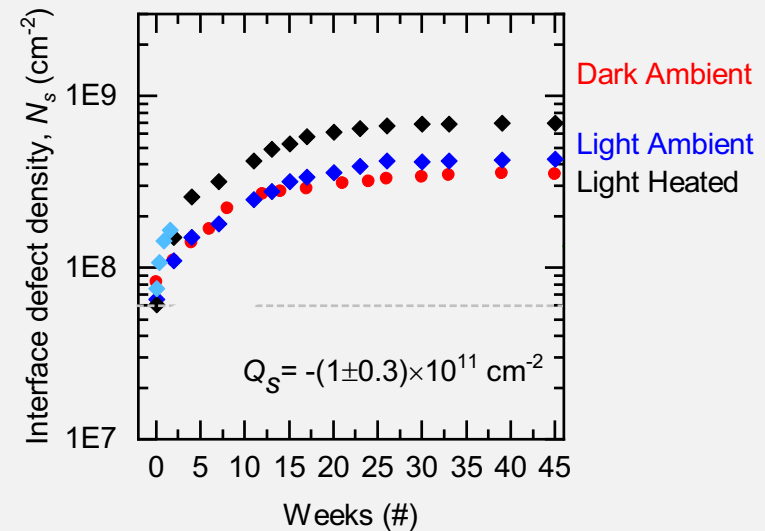
$$t(\text{norm}) \sim t(\text{acc})^s$$
$$s = 0.85 = T(\text{acc})/T(\text{norm})$$

Remarkable confirmation

## II. Experimental analysis of SHJ degradation

Bertoni, Mazoor:

- Created c-Si/a-Si:H stacks with 12% H
- Extracted surface recombination velocity using the temperature- and injection-dependent lifetime spectroscopy technique over 45 weeks
- $N(t)$  well-fitted with stretched exponential
- Stretching exponent bigger than in Si-only simulation. Probably because barrier for H migration is much smaller than for Si migration.

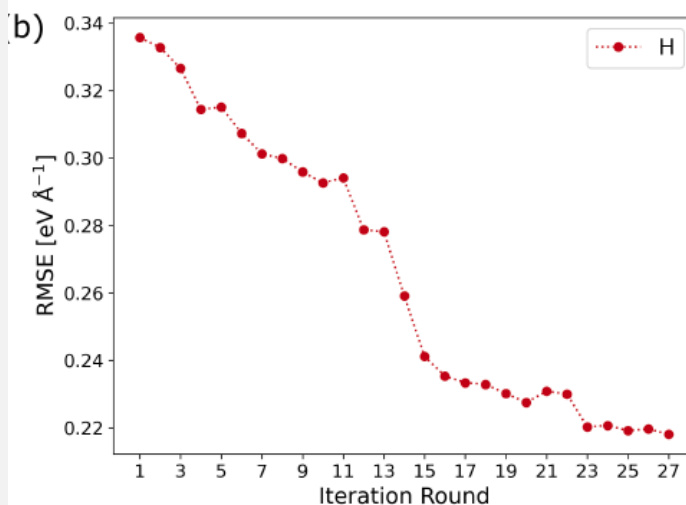


# III. For SolDeg for c-Si/a-Si:H – Need Machine-Learning based Si-H GAP

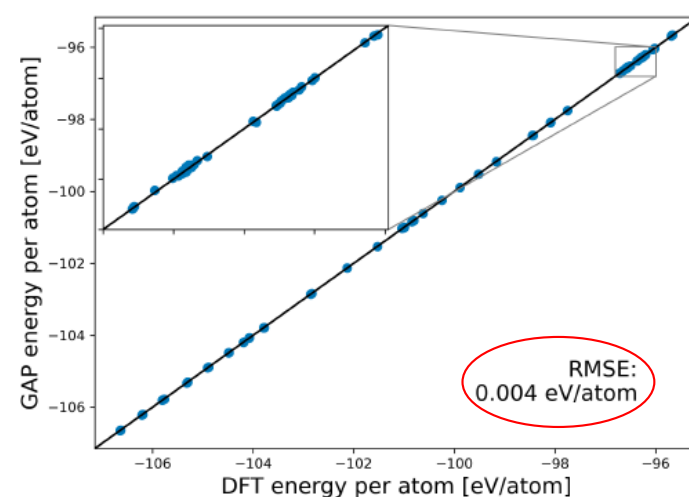
Problem: no Machine Learning-based Si-H (GAP) potential

We developed the world's first Si-H Machine Learning-based GAP potential

| Iteration | Structure Type                                                                 |
|-----------|--------------------------------------------------------------------------------|
| 1         | Optimized structures (all phases)                                              |
| 2         | Optimized structures (all phases)                                              |
| 3         | Low T anneal of a-Si:H                                                         |
| 4         | High T anneal of liq-Si:H                                                      |
| 5         | High T anneal of liq-Si:H                                                      |
| 6         | Med T anneal (1100K) of a-Si:H                                                 |
| 7         | Heating a-Si:H from 500K to 800K at $10^{13}$ K/s                              |
| 8         | Heating a-Si:H from 800K to 1100K at $10^{13}$ K/s                             |
| 9         | Heating a-Si:H from 1100K to 1400K at $10^{13}$ K/s                            |
| 10        | Heating a-Si:H from 1100K to 1400K at $10^{13}$ K/s                            |
| 11        | Heating a-Si:H from 800K to 1400K at $10^{12}$ K/s                             |
| 12        | Added new a-Si:H structures                                                    |
| 13        | Add new a-Si:H structures                                                      |
| 14        | Added c-Si/a-Si:H interface structures                                         |
| 15        | Added c-Si/a-Si:H interface structures                                         |
| 16        | Added new c-Si divacancy structures                                            |
| 17        | Added new liq-Si:H structures                                                  |
| 18        | Added new c-Si vacancy structures                                              |
| 19        | Added new c-Si interstitial structures                                         |
| 20        | Low T anneal of c-Si/a-Si:H interface structures                               |
| 21        | Optimization of c-Si/a-Si:H interface structures                               |
| 22        | NPT high T anneal of liq-Si:H structures                                       |
| 23        | NVT high T anneal of liq-Si:H structures                                       |
| 24        | Quenching liq-Si:H from 2000K to 1500K at $10^{13}$ K/s                        |
| 25        | Annealing quenched liq-Si:H structures at 1500K                                |
| 26        | Quenching liq-Si:H from 1500K to 1400K at $10^{12}$ K/s                        |
| 27        | Added hydrogen passivated c-Si surface (100) and c-Si surface (111) structures |



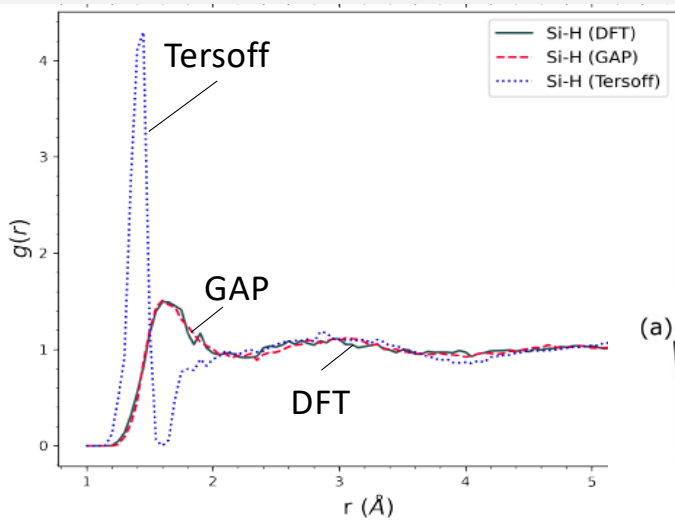
Forces: Deviation from DFT  
substantially reduced



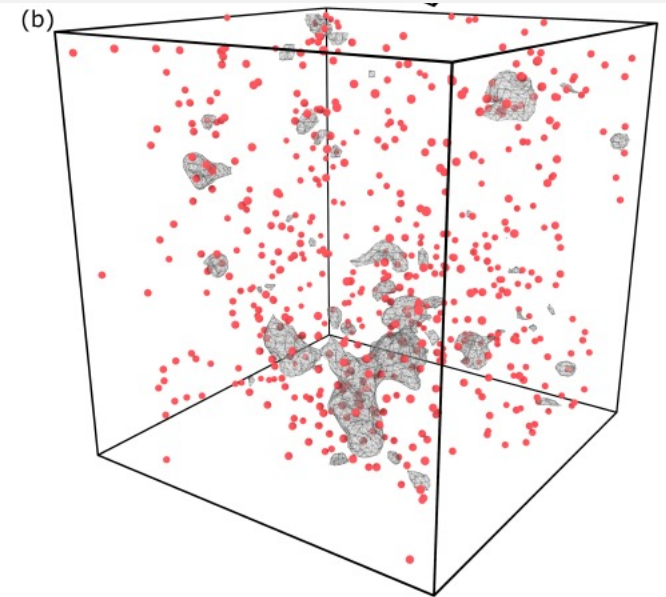
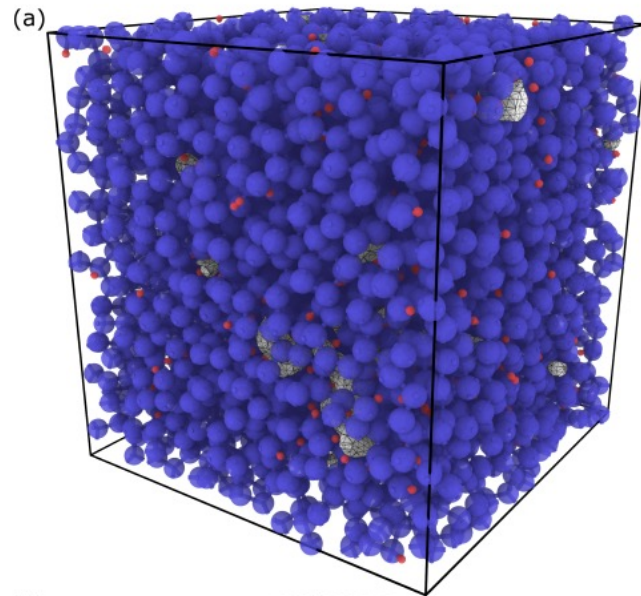
Energies: reproduces DFT  
within 4 meV/atom



# Machine-Learning based Si-H GAP



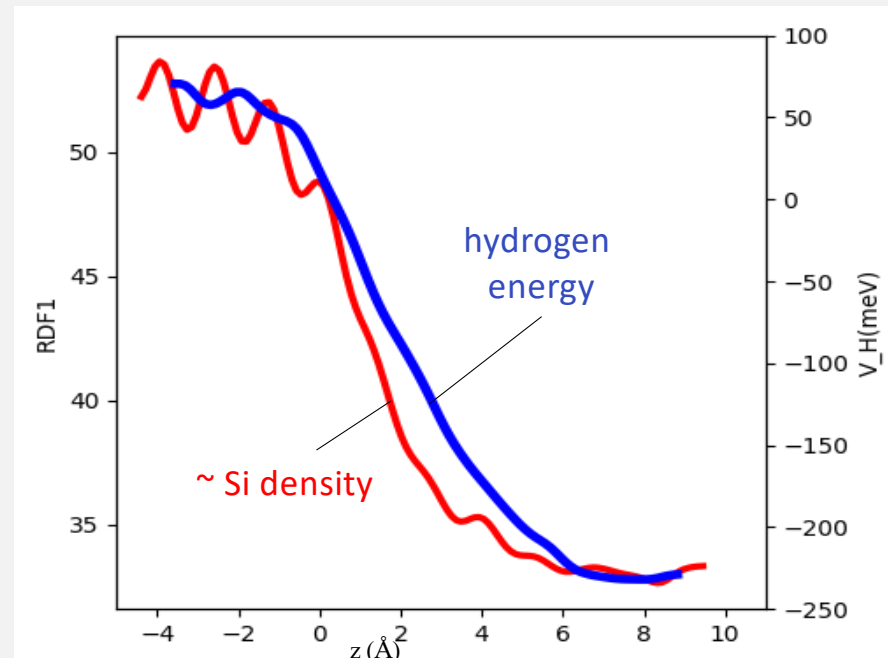
Run time scales with  $N$ , not with  $N^3$ , like DFT  
Thus, here is a simulation  $\sim 4,600$  Si and H atoms,  
completely unreachable for DFT



Our Si-H GAP reproduces DFT  
correlator qualitatively better  
than Tersoff

## IV. Repeat SolDeg for c-Si/a-Si:H with Si-H GAP

1. Created 60 c-Si/a-Si:H stacks.
2. Inserted H to ~500 positions into each of the 60 stacks and measured its energy (blue). This represents 30,000 calculations.
3. Gradient of hydrogen energy creates a force that drives H atoms away from SHJ interface!
4. What created H energy gradient? We measured Si density (red).
5. The Si density gradient correlates with, and likely causes, the hydrogen energy gradient

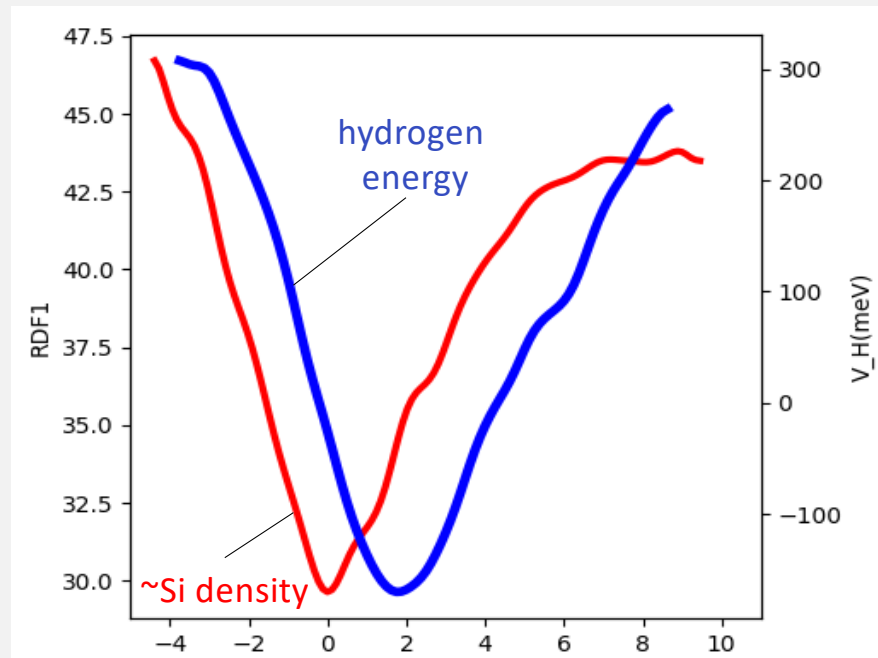


The Si density gradient across interface creates a force that drives H away from interface, degrading the SHJ cell passivation

# How to stop H degradation? NoDeg cells

1. The H energy gradient was created by the Si density gradient.
2. Therefore, we expect that if we create a minimum for the Si density at the interface, the H energy gradient can be changed into an H energy valley, stabilizing the passivation.
3. We created 60 new c-Si/a-Si:H stacks where the Si density had a minimum at the interface. Again measured the H energy at 30,000 positions. Found that the H energy gradient has been eliminated!

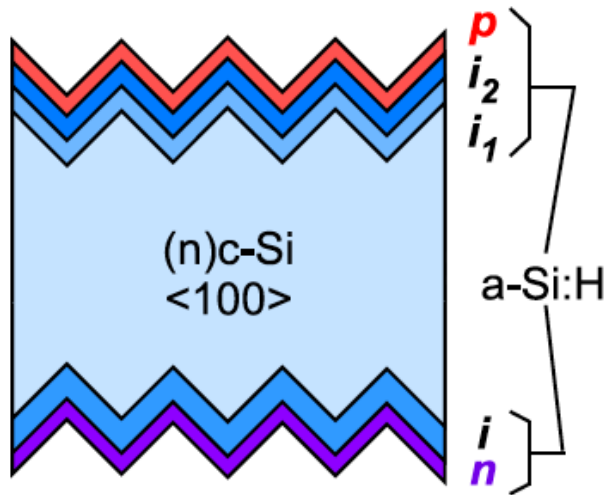
Creating a Si density minimum at the interface preserve the H passivation at the interface.



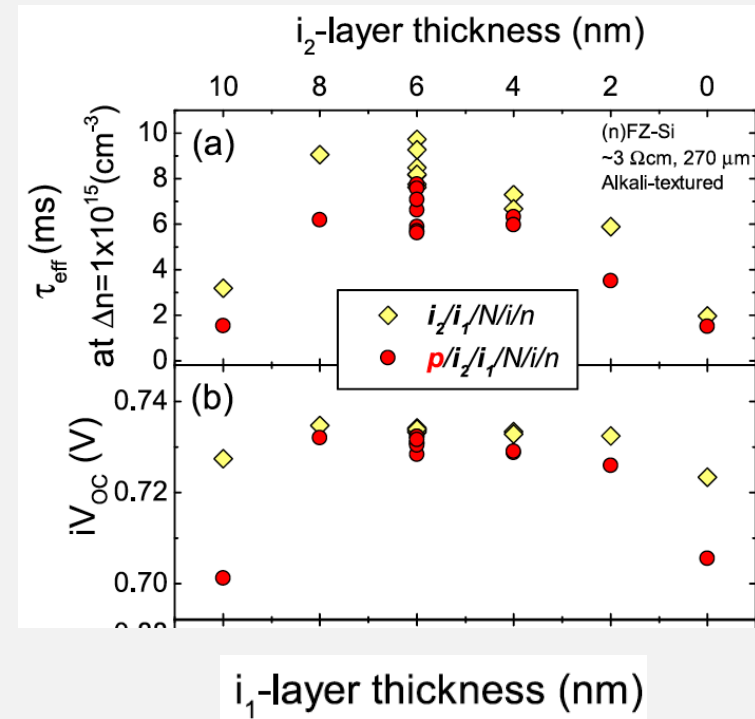
# Possibly relevant experiments

Sai et al. J. Appl. Phys.  
124, 103102 (2018)

(b) Passivated wafer



“Surface passivation at the a-Si:H/c-Si interface is significantly improved by using an intrinsic a-Si:H bilayer, i.e., a stack of an interfacial layer with a large  $R^*$  and an additional dense layer”



# SUMMARY

1. Developed SolDeg platform to analyze defect dynamics that bridges 24 orders of magnitude in time
2. In Si-only SHJs found that defect generation follows a stretched exponential
3. Discovered scaling law of accelerated testing:  $t(\text{norm}) \sim t(\text{acc})^{T(\text{acc})/T(\text{norm})}$
4. Reported experimental analysis of SHJ degradation
5. Developed Machine-Learning-based Si-H GAP potential for most accurate Molecular Dynamics simulation of c-Si/a-Si:H SHJs with many thousands of atoms
6. Performed SolDeg simulation of c-Si/a-Si:H SHJs
7. Determined H energy that drives H away from SHJ interface, thereby degrading the cell passivation
8. Proposed modified SHJ architecture where the H-drift degradation channel is blocked

- ACS Applied Materials & Interfaces 2021, 32424
- arxiv 2106.02946 - submitted to Phys. Rev. Mat.
- To be submitted this week